



1752
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Junichi KON et al.**

Group Art Unit: **1752**

Serial No.: **10/614,236**

Examiner: **Sin J. LEE**

Filed: **July 8, 2003**

Confirmation No.: **6187**

For: **CHEMICALLY AMPLIFIED RESIST MATERIAL AND PATTERNING
METHOD USING SAME**

Attorney Docket No.: **030820**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

June 1, 2004

Sir:

In response to the Office Action dated January 30, 2004, the response date of which having been extended by one month to May 30, 2004, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.